26th World Gas Conference

1 – 5 June 2015, Paris, France



New Gas Quality Sensor for « Mass Market » Applications

Dr. Philippe Prêtre MEMS AG, Switzerland

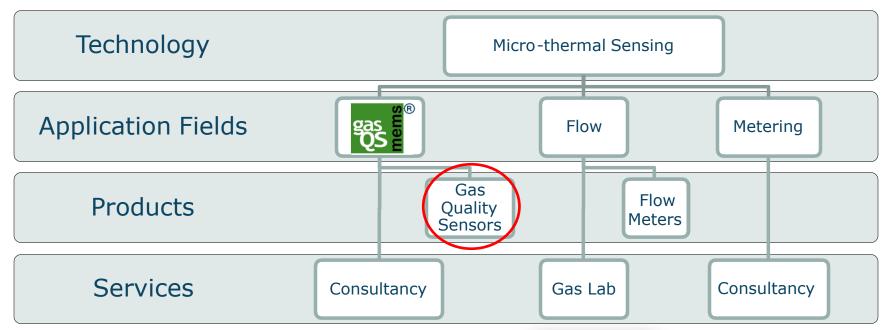


MEMS AG, 5413 Birmenstorf, Switzerland

- Matter Engineering for Metering Systems alias
- Micro Electro-Mechanical Systems
- since 2003
- Employees: 16
- www.mems.ch
- Gas measuring technologies
- Electronics developments



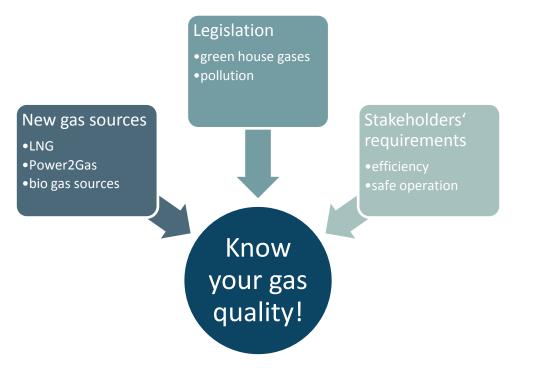
MEMS AG: Gas Measuring Technologies





Gas quality, a growing concern for end users?

Why gas quality sensors for the gas industry?



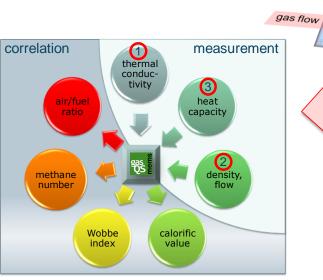
Available sensor technologies

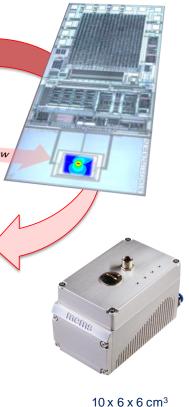
Technology	Measured quantity	Pros +	Cons -	Costs	Main- tenance	Size	Robust- ness
Gas Chroma- tographs	gas composition	high accuracy	not for all gas types	high	high	large	low
Calorimeters	Wobbe, calorific value	direct measure- ment, no limitation on gas quality	only Wobbe, calorific value	high	high	large	low
Optical	gas composition	high selectivity	limited gas range	high	medium	medium	low
Correlative methods	physical sum parameters	response time	reduced accuracy	high	low	medium	medium
No devid	ces availa	ble yet!	low	low	small	high	

Micro-thermal chip sensing technology

CMOS chip technology

- fully integrated hot-wire anemometer
- standard industrial production process
- potentially cheap





3.5 x 2.1 mm²



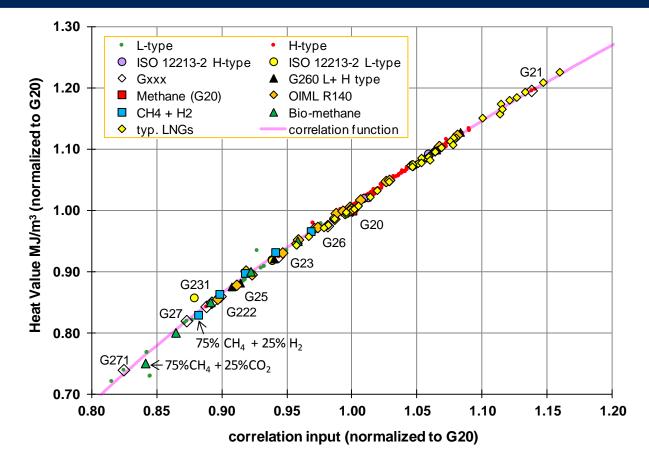
Gas quality sensing

- correlative measurement method
- IP owned by MEMS AG
- Technology registered as gasQS[®]

Advantages

- fast response
- compact size
- robustness
- low maintenace
- no re-calibration
- no reference gas
- ease of integration into a control system

Correlation example: heat value



Performance

for the full gas range shown on previous slide

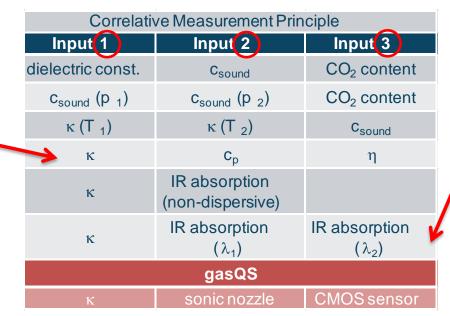
Gas quality	Accuracy	Stability
Calorific value	2 % rel.	0.2% rel.
Methane number	+/- 3 abs	+/- 2 abs
Wobbe index	2 % rel.	0.2% rel.
Density	2 % rel.	0.2% rel.
Gas temperature	+/- 0.5 K	+/- 0.1 K
Thermal conduct.	1 % rel.	0.3 % rel.

higher accuracy for selected gas types, e.g. LNGs

Correlative measurement methods

EMC500: > 20'000 \$

Source: RMG Honeywell



Gas Lab Q1: > 20'000 \$



Source: Elster



Available sensor technologies

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Now ava	ailable!		<	low	low	small	high
					1		

competitive positioning of the gasQS technology

OEM sensor version

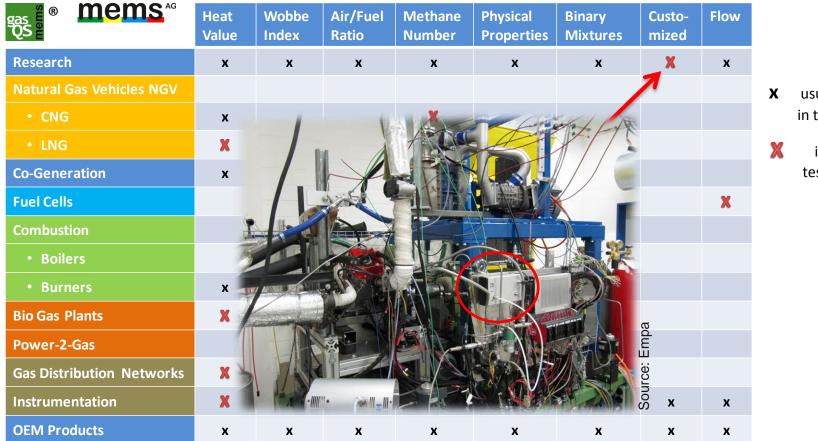
- Samples available @ MEMS
- compact (100 x 60 x 62 mm3)
- for field tests
- ease of operation
- support by MEMS
- service package: 25 k€



QS e mems ^{AG}	Heat Value	Wobbe Index	Air/Fuel Ratio	Methane Number	Physical Properties	Binary Mixtures	Custo- mized	Flow		
Research	x	х	x	x	x	x	X	х		
Natural Gas Vehicles NGV									х	usua
• CNG	x			X						in thi
• LNG	X			x					X	im
Co-Generation	x		x	x						test
Fuel Cells			X					X		
Combustion										
• Boilers		х								
Burners	x		x							
Bio Gas Plants	X					CO2/CH4				
Power-2-Gas						H ₂ /CH ₄				
Gas Distribution Networks	X									
Instrumentation	X	х	x	x	x	x	x	x		
OEM Products	x	х	x	x	x	x	x	x		

usually asked for in this application

implemented / tested by MEMS



- usually asked for in this application
- implemented / tested by MEMS

e mems ^{ac}	Heat Value	Wobbe Index	Air/Fuel Ratio	Methane Number	Physical Properties	Binary Mixtures	Custo- mized	Flow	
Research	х	х	x	x	x	x	X	x	
Natural Gas Vehicles NGV									Х
• CNG	х			x					
• LNG	X			×					X
Co-Generation	х			\$\$ \/s	S. A.				
Fuel Cells			1/2		63	0		X	
Combustion					10 M	115			
• Boilers		х		2	in the man	- Jos	* 11 1 m		
• Burners	х					ns.			
Bio Gas Plants	Х		-		P		/	1	
Power-2-Gas			6			3-0			
Gas Distribution Networks	X			NO 1	. 10	110			
Instrumentation	X	х	1	1	and the second of the		°	x	
OEM Products	х	x	X	X	X	×	×	x	

- usually asked for in this application
- implemented / tested by MEMS

QS e mems ^{AG}	Heat Value	Wobbe Index	Air/Fuel Ratio	Methane Number	Physical Properties	Binary Mixtures	Custo- mized	Flow	
Research	х	х	x	x	x	x	X	x	
Natural Gas Vehicles NGV									х
• CNG	х			X					
• LNG	X			x					X
Co-Generation	х		x						
Fuel Cells			x					7 X	
Combustion			~			27/			
• Boilers		x		1 Contraction					
• Burners	х		x	6		1 Com			
Bio Gas Plants	X			XIS			0		
Power-2-Gas				HE, HE,		- Could	Xi		
Gas Distribution Networks	X				Let and the address of the address o		He		
Instrumentation	X	х	x		V	/	Source: Hexis	х	
OEM Products	х	x	x				Ň	x	

- usually asked for in this application
- implemented / tested by MEMS

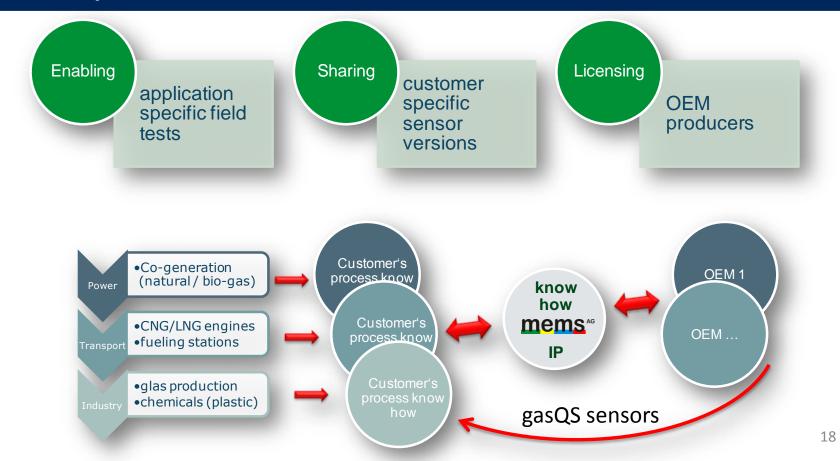
	Heat Value	Wobbe Index	Air/Fuel	Methane	Physical Properties	Binary Mixtures	Custo- mized	Flow	
Research	x	x			x	x	X	х	
Natural Gas Vehicles NGV			1						х
• CNG	х		V >	2 2 1					
• LNG	Ж	1	1 al		1				>
Co-Generation	х	1	X						
Fuel Cells								X	
Combustion									
Boilers		х							
Burners	x		TO S						
Bio Gas Plants	Ж		12			CO2/CH4			
Power-2-Gas				AND SCORES		H ₂ /CH ₄			
Gas Distribution Networks	X								
Instrumentation	X	x	x	x	x	x	x	x	
OEM Products	х	x	x	x	x	x	x	x	

- usually asked for in this application
- implemented / tested by MEMS

	Heat Value	Wobbe Index	Air/Fuel Ratio	Methane Number	Physical Properties	Binary Mixtures	Custo- mized	Flow
Research	x	x	x	x	х	x	X	x
Natural Gas Vehicles NGV								
• CNG	x		4 .		A			
• LNG	X				XX		12	
Co-Generation	x		I		Ne			
Fuel Cells				A DECEMBER OF THE OWNER	yo i	2		X
Combustion					THE OWNER OF			
• Boilers		x			4	. / 7/2	100	
• Burners	x				mems			
Bio Gas Plants	X		Vent of the					
Power-2-Gas				and the second	Contraction of the	d		
Gas Distribution Networks	x 🚄		and the second second	and the second second		and the second		
Instrumentation	X	x	x	x	x	x	х	x
OEM Products	x	x	x	x	x	x	x	x

- x usually asked for in this application
- implemented / tested by MEMS

Market penetration



Contact

Come and visit us at booth K58!

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